# **Evaluation of the Performance of** SiPM-on-Tiles at the End of Life of the CMS HGCAL Upgrade

**Phase-II Upgrade of the CMS Endcap Calorimeters** 

#### Malinda de Silva

DPG Spring Meeting, Dresden 22<sup>nd</sup> March 2023













### **Overview**

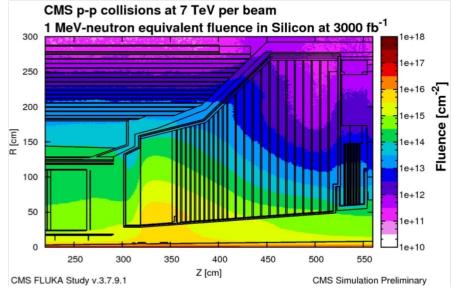
### **Evaluation of the Performance of SiPM-on-Tiles at the End Of Life of the CMS HGCAL Upgrade**

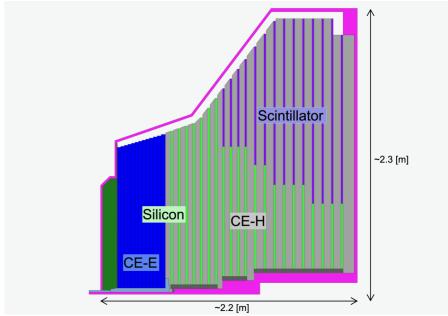
- Introduction to the CMS HGCAL Upgrade
  - Scintillator Section of the HGCAL Upgrade
- Signal-to-Noise Requirement for the Scintillator Section
- Model, Data Acquisition and Results used for SNR Extrapolations
- Updated Signal-to-Noise Ratios at end of life
- Summary

**High Granularity for the High Luminosity LHC** 

### **Phase II Upgrade of the CMS Endcap Calorimeter (HGCAL)**

- HL-LHC aims to achieve an integrated luminosity of 3000 fb<sup>-1</sup> by its end of life
  - Ten times higher than the LHC
  - Poses significant challenges for radiation tolerance and event pileup on detectors
- CMS endcap calorimeter to be replaced with a 5D (imaging) calorimeter using particle flow
- The active area of CMS endcap calorimeter (HGCAL) will consist of:
  - silicon detector section
  - scintillator section: where radiation levels permit (neutron fluence < 5x10<sup>13</sup> n/cm<sup>2</sup>)

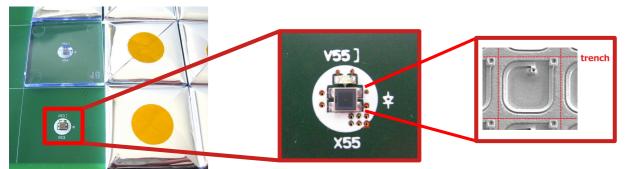




# Scintillator Component of the Hadronic Endcap Calorimeter

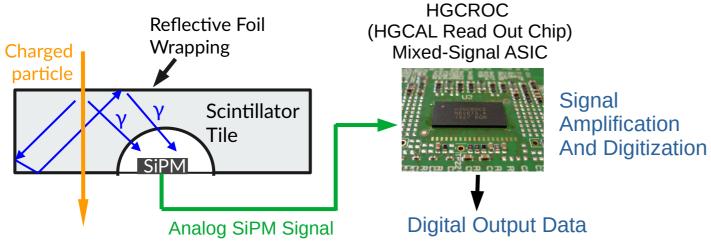
#### SiPM-on-Tile Based Read-out

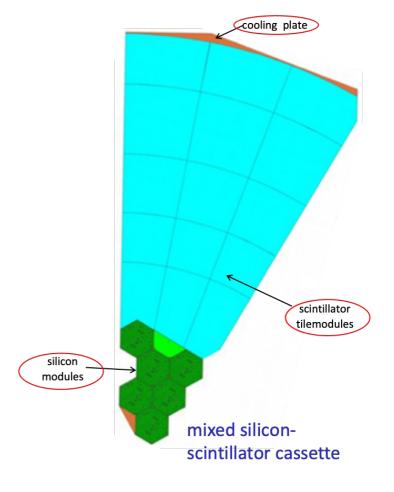
 SiPM-on-tiles consist of individually wrapped plastic scintillator tiles placed on silicon photomultipliers (SiPM)



SiPM consists of 1000s of Single Photon Avalanche Diode (SPAD)

The signals from SiPM-on-tiles are read out by the HGCROC front end electronic ASIC

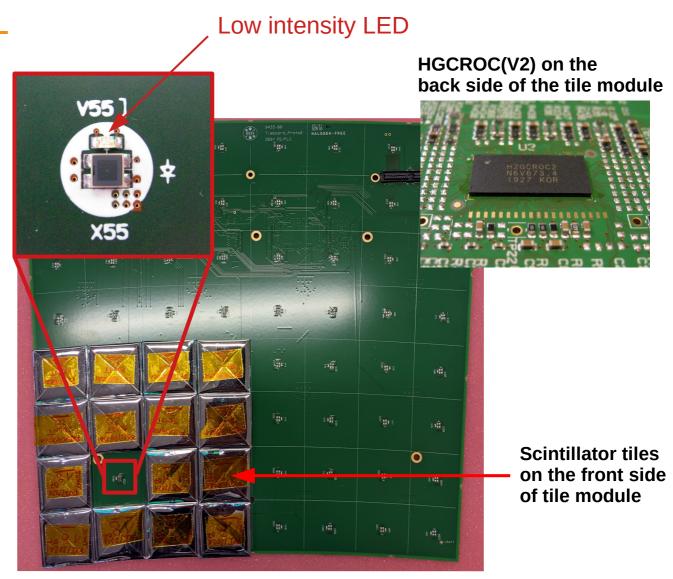




### **CMS HGCAL Tile Module**

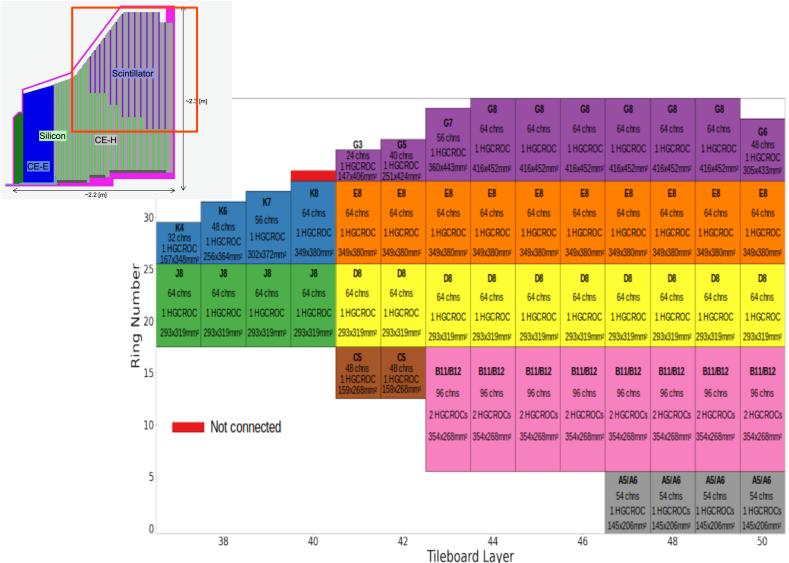
For the Scintillator Section of the CMS HGCAL

- The basic detector unit in the SiPM-on-tile section is the tile module.
- Consists of a PCB, HGCROC, SiPMs, scintilators and other on-board electronic systems.
- Most tile modules will hold one HGCROC
- HGCROC can reads out up to 72 channels simultaneously.



### **Current Tile Module Plans For the HGCAL Scintillator Section**

### Tile Module Layout in a 10° Sector



- 8 tileboard types cover the entire area
  - Includes 35 tileboard variants
- More than 240,000 SiPM-on-tile channels
- Scintillator tiles:
  - 21 different tile sizes.
  - 23 mm to 55 mm side length
  - Covering an area of 340 m<sup>2</sup>
- SiPMs: Hamamatsu HDR-2, 15 µm pitch sized SiPMs with custom radiation hard packaging with good thermal conductivity
  - 2x2 mm² active area SiPMs
  - 3x3 mm² active area SiPMs

# Signal-to-Noise Requirement for Scintillator Section of HGCAL

At End-of-Life: integrated luminosity of 3000 fb<sup>-1</sup>

- Minimum ionizing particles (MIP) will be used as a standard candle for energy calibration for each SiPM-on-tile until end of life
- SiPM-on-tiles are not as radiation hard as silicon sensors:
  - Will be used in areas where a signal-to-noise ratio (SNR) > 3 for MIPs can be maintained
- Mathematical model used to predict the SNR at end of life:
  - SiPM-on-tile performance before irradiation
  - Increase in SiPM noise with irradiation
  - Degradation of scintillator performance with irradiation rate
- Model needs to be updated with the latest results to ensure that the performance of the detector maintains SNR > 3

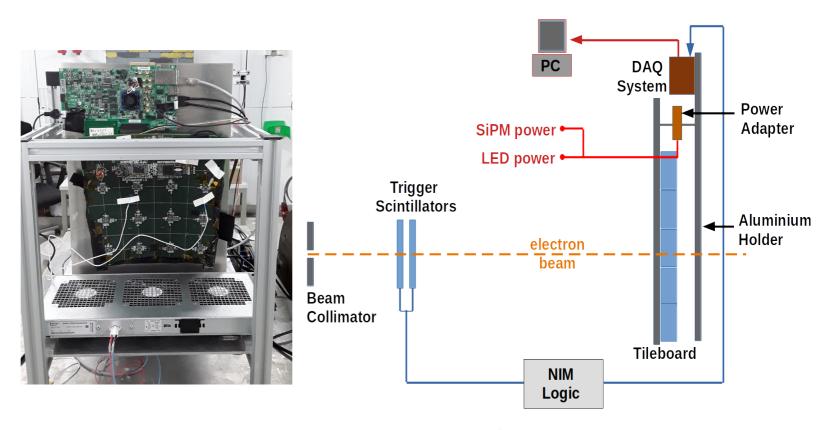
# **Quantifying SiPM-on-Tile Performance at Start Of Life**

#### **At Beam Tests**

 Unirradiated SiPMs and scintillators on HGCAL tileboard prototypes measure the performance expected at the starting conditions of the detector

- SiPM-on-tile performance measured at DESY II test beam facility
  - 3 GeV electrons (has similar response to MIPs)
  - 30,000-100,000 events at a SiPM over-voltage of 2V

11 test beams to date since 2020



# **Light Yields of SiPM-on-Tiles**

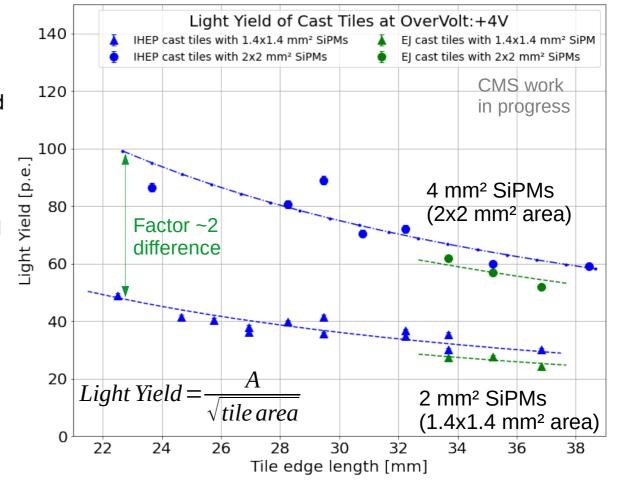
### **Using MIP and SiPM Gain measurements**

- The SiPM signal response to MIPs re-scaled by the SiPM's gain is defined as light yield
  - Purely optical property solely dependent on the SiPM and scintillator

 Light yields measured for different scintillator sizes and SiPM sizes can be fitted using relation :

$$Light Yield = \frac{A(4 mm^2)}{\sqrt{tile area}} \times \frac{SiPM \ active \ area}{4 mm^2}$$

Smaller tiles and larger SiPMs give larger light yields



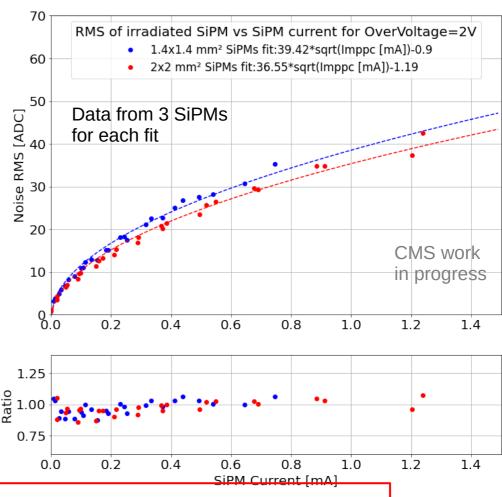
### **SiPM Noise Measurements with Irradiated SiPMs**

#### **Results**

- Fluence increases the leakage current passing through of SiPMs
- Leakage current increases the SiPM noise

$$Pedestal\ noise = (A \times \sqrt{SiPM\ current} + B)$$

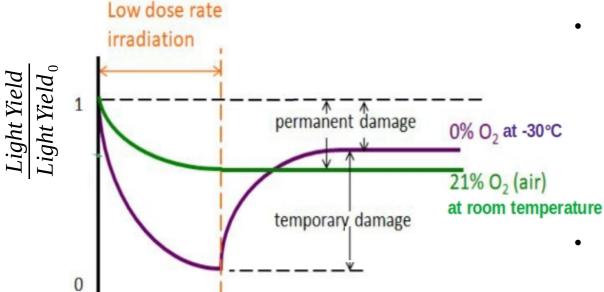
- Methodology:
  - Measure noise and current at different temperature while maintaining a 2V over-voltage
- The fit parameters can be used to re-scale the expected noise at any fluence and luminosity of all SiPMs of all sizes



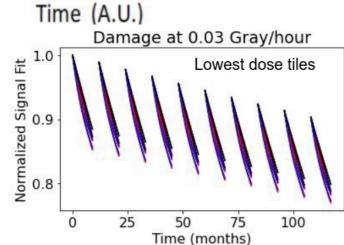
$$\left(\frac{Pedestal\ Noise\ of\ any\ SiPM}{Pedestal\ Noise\ at\ 5\times10^{13}\ n/cm^{2}}\right) = \sqrt{\left(\frac{fluence}{5\times10^{13}\ n/cm^{2}}\right)} \times \left(\frac{integ\ .\ lumi}{3000\ fb^{-1}}\right) \times \left(\frac{SiPM\ active\ area}{2\ mm^{2}}\right)$$

## **Degredation of Scintillator Tile with Radiation**

#### **Permanant and Temporary Damage**



\* Plots courtesy of S. Eno and B. Kronheim (Maryland University)



- Two types of damage to scintillator:
  - Permanent light loss in scintillator
  - Temporary (annealing) light loss

#### For light yield extrapolation model

- 9 months of operation causing both temporary and permanent damage
- 3 months of total annealing of temporary damage during shutdown

# Signal to Noise Ratios at End of Life (at 3000 fb<sup>-1</sup>)

#### 10° sector of the scintillator section of the HGCAL

Since Light Yield is known and noise is known for a given fluence and dose rate, the SNR at any given time can be calculated using:

$$SNR = \frac{Light\ Yield}{Pedestal\ Noise}$$

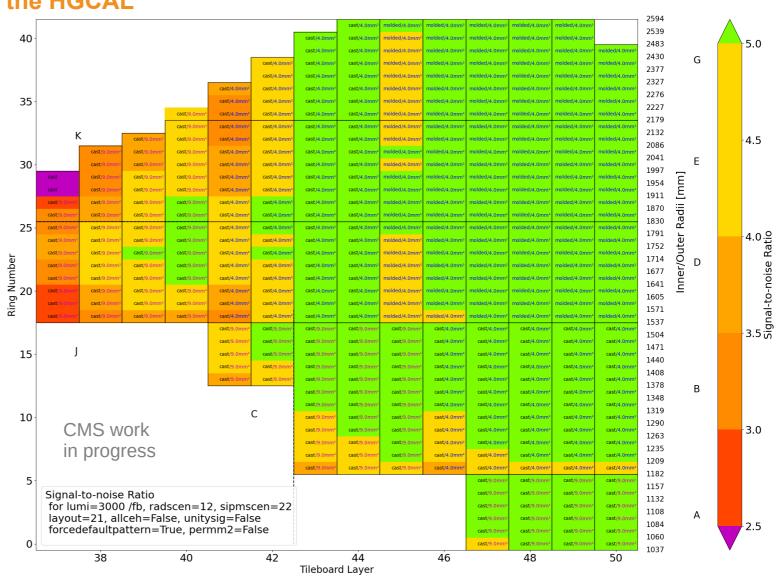
# Signal to Noise Ratios at End of Life (at 3000 fb<sup>-1</sup>)

#### 10° sector of the scintillator section of the HGCAL

Since Light Yield is known and noise is known for a given fluence and dose rate, the SNR at any given time can be calculated using:

$$SNR = \frac{Light\ Yield}{Pedestal\ Noise}$$

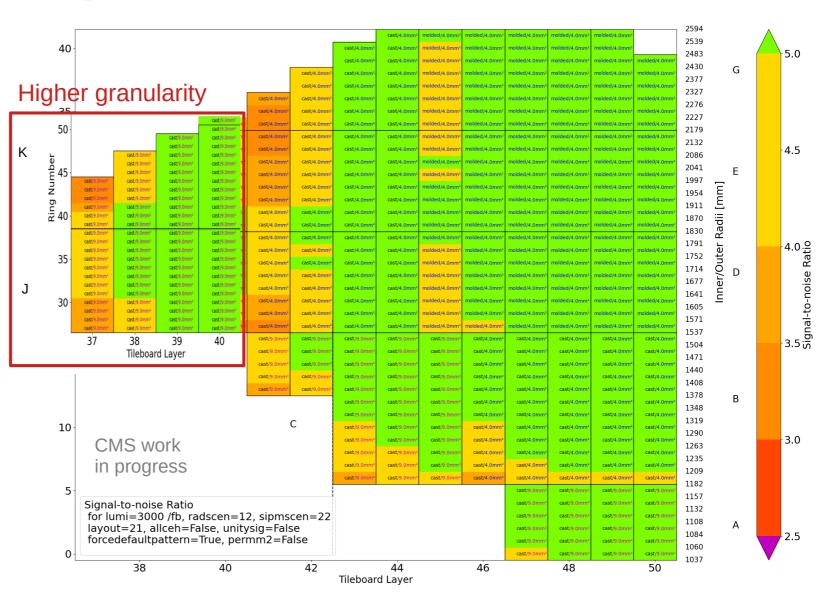
- Each layer consists of 8 SiPM-on-tile channels
- Most SiPM-on-tile channels maintains SNR>3 at end of life (3000 fb<sup>-1</sup>)
  - Front layer are the only exception



# Possible Solutions to Improve SNR for J and K Tileboards

#### More SiPM-on-Tile Channels

- It is possible to improve the SNR in first 4 layers to have smaller tiles and more SiPM
  - Fit 3x3 channels in an area previously containing 2x2 channels
  - Will require the change in hardware design of tileboard types J and K
- Alternative solution: Convert layer 37 to a fully silicon layer



# **Summary**

### **Extrapolation of Signal-to-Noise Ratios for End of Life Conditions**

- HGCAL uses SiPM-on-Tile technology in demanding radiation conditions for the first time
  - Scintillation light decreases with irradiation
  - SiPM noise increases with irradiation
- However, MIP sensitivity is required for the calibration up to end of life
- Studies of initial performance with realistic prototypes, and with irradiated SiPMs provide firm basis for optimised configuration of detector and safe operation throughout HL-LHC
- Commissioning period will be challenging with rapidly varying conditions

# Thank you for your attention!

DESY. Page 15

# Backup

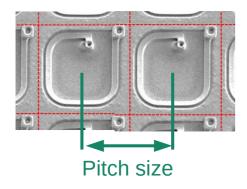
DESY. Page 16

# SiPM-on-Tile technology

#### **SiPM Paramater Definitions**

#### Pitch size :

The distance between two adjacent cell (SPAD) centers in the SiPM



#### SiPM active area :

The SiPM area capable of detecting photons

#### Overvoltage (OV):

Difference between bias voltage and breakdown voltage above which Geiger discharge becomes possible

$$Overvoltage = (Bias\ voltage) - (breakdown\ voltage)$$

#### • SiPM gain:

The charge amplification factor of the SiPM cells

$$SiPM Gain = \frac{(Charge Collected per SPAD)}{(Charge of an electron)}$$

#### Photon detection efficiency (PDE) :

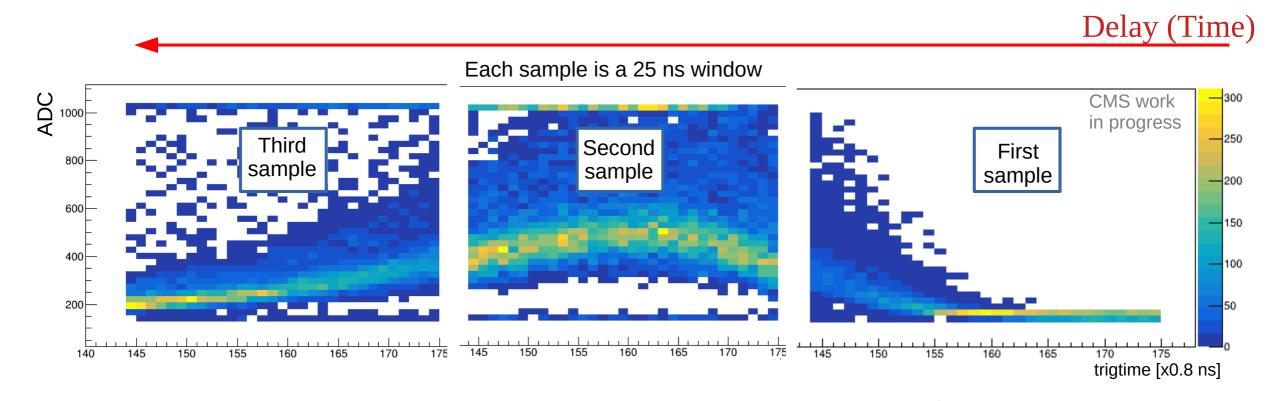
Efficiency at which SiPMs can detect photons

Both SiPM gain and PDE depend on the overvoltage

# **Data Analysis with Trigger Time Readout**

#### **Pulse Shape of 3GeV Electron Events**

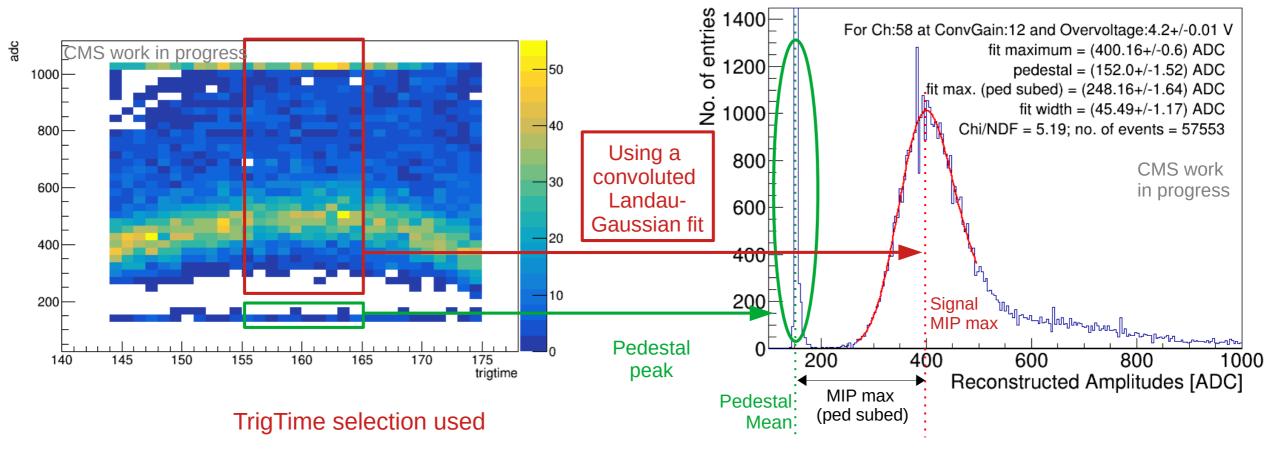
- DESY II beam is asynchronous to the HGCROC clock.
  - Introduces a 25 ns uncertainty to the pulse amplitude position
- The TB-tester DAQ used, saves the time stamp of trigger with ~0.8 ns resolution



# MIP Extraction using Pulse Shape and Trigger Information

### **Using Trigger Time and Signal Amplitude**

Using a simple time selection for in-time MIP signals, it was possible to extract the MIP spectra



(Pedestal subtracted MIP max.) = (MIP max. of signal) – (Pedestal mean)

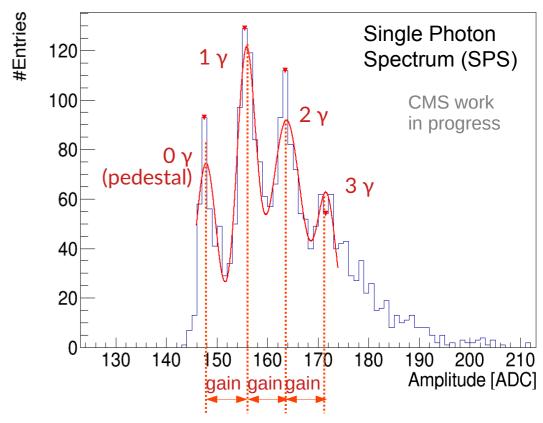
# **Overview of SiPM Gain Analysis**

### Using Single Photon Spectra (SPS) from On-Board LED System

• The LED system on-board the tileboard pulses the low intensity LEDs.



- The photons produced by the LEDs are detected by the SiPMs
  - Pulses from SiPM are sampled at the pulse amplitude
  - Resulting histogram shows the pedestal peak and peaks corresponding to the number of SiPM cells discharged due to photon detection
    - Often referred to as a Single Photon Spectrum (SPS)



- A multi-gaussian function is used to find the mean distance between peaks in the resulting histogram
  - This measures the gain of the SiPM in ADC units

# Quantifying SiPM-on-Tile Performance at Start Of Life

#### **At Beam Tests**

- MIP extraction from beam data:
  - SiPM pulse sampled at amplitude using trigger timestamps from the DAQ system
  - Resulting histogram follows a Landau-Gaussian function from which the MIP maxima is extracted
    - Pedestal is subtracted from MIP maxima

- SiPM gain extraction from LED data:
  - The photons produced by the LEDs are detected by the SiPMs, whose pulse amplitudes are sampled.
  - Resulting histogram is a single photon spectrum (SPS) where the difference between consecutive peaks is defined as SiPM gain
- Ratio between MIP maxima and SiPM gain gives a purely optical performance measurement defined as light yield

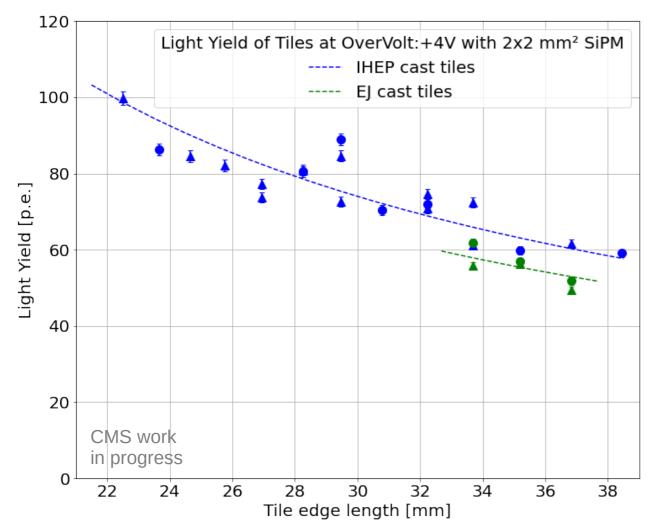
$$Light Yield[p.e.] = \frac{MIP maxima[ADC]}{SiPM gain[ADC]}$$

• Light yield depends on SiPM's active area, tile size and scintillator and wrapping properties

$$Light Yield = \frac{A(4 mm^2)}{\sqrt{tile area}} \times \frac{SiPM \ active \ area}{4 mm^2}$$

# **Light Yields of SiPM-on-Tiles**

#### Variation with SiPM size



- Light yield also varies as a function of SiPM active area
- Therefore one can calculate all light yields with respect to the 2x2 mm<sup>2</sup> SiPMs:

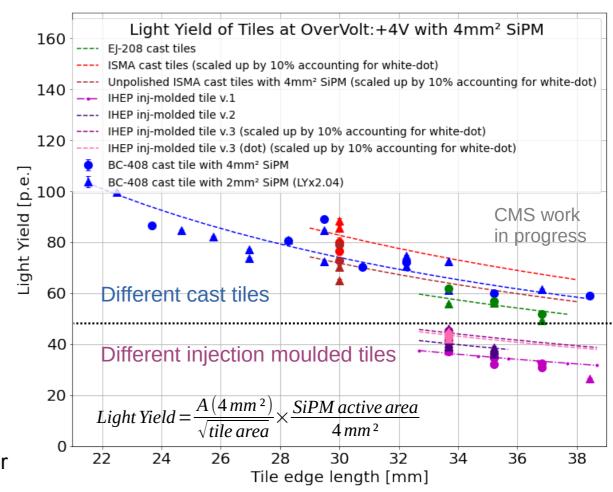
$$Light Yield = \frac{A(4 mm^2)}{\sqrt{tile area}} \times \frac{SiPM \ active \ area}{4 mm^2}$$

- 3x3 mm² SiPMs will have 2.25 times more light yield than 2x2 mm² SiPMs
- More light from smaller scintillators.
- Both these help increase the signal in more irradiated regions

# **Light Yield Variation with Scintillator Tile**

#### **For Different Types of Scintillators**

- Light yields shown uses two methods of production:
  - Cast Tiles:
    - Produced using polyvinyl toluene (PVT)
    - Bought as sheets which needs to be machines into tiles
    - Expensive but better performance
  - Injection-moulded Tiles:
    - Produced using polystyrene
    - Produced by injecting heated molten material to moulds which is then cooled down to solidify
    - Cheaper but lower light yields
- Best performing tiles of both types will be used in final detector such that SNR>3 is maintained



DESY.

### **SiPM Noise Measurements with Irradiated SiPMs**

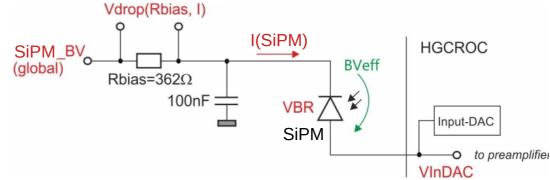
### Methodology

- Fluence increases the leakage current passing through of SiPMs
- SiPM noise is an ADC measurement of the fluctuation of leakage current:

$$Pedestal\ noise = (A \times \sqrt{SiPM\ current} + B)$$

 A and B values measured using tile modules with HGCAL readout can be used to calculate SiPM noise in terms of current





# Relationship between Noise and Current passing through SiPM

### **Theoretical Background**

- When using different temperatures (or light intensities) to vary SiPM noise for a fixed overvoltage, the current also increases as a function of SiPM noise
  - For a SiPM with negligible excess noise factor caused by after-pulsing and crosstalk

$$I = \frac{N \cdot G \cdot e}{\Delta t}$$

N = no. of fired pixel in time  $\Delta t$ 

G = SiPM gain

e = electron charge

 $\Delta t$  = time period

• 
$$Q = \int I \cdot dt = N \cdot G \cdot e$$

• Since the noise scales as a function of  $\sqrt{N}$  :

noise RMS = 
$$\sqrt{N} \cdot G \cdot e = \sqrt{I} \cdot \sqrt{G \cdot e \cdot \Delta t}$$

• That is, for a given overvoltage:

*noise RMS*  $\propto \sqrt{SiPM}$  *current* 

# **SNR** of Best and Worst Performing Channel of Tileboard Type

### For Tileboard Type A and B

- Each year delivers 300 fb<sup>-1</sup> of integrated luminosity
- All Tileboards of type A and B maintains a SNR>3 throughout the detector lifetime
  - Similar plots can be produced for all SiPM-on-Tiles

